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U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10039357	FILING DATE 11/07/2001	CLASS 257	SUBCLASS	GAU 2811	EXAMINER <i>ZERVIGON</i>
<b>**APPLICANTS:</b> Park Chang Soo, Park Sang Gee, Choi Jung Hwan, Chung Bo-Shin, Oh Sang-Young, Lee Eung-Soo.					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>** FOREIGN APPLICATIONS VERIFIED</b> REPUBLIC OF KOREA 2000-65873 11.07.2000					
PG-PUB DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>					
Foreign priority, claimed 35 USC 119 conditions met Verified and Acknowledged Examiners initials				ATTORNEY DOCKET NO TJK 203 LW	
TITLE : Apparatus and method for thin film deposition					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner PREPARED FOR ISSUE Application Examiner	
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